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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**SUBMISSION OF CORRECTED DRAWINGS**

APPLICANTS: Fumihiko Nakamura et al. ATTY DOCKET NO: 09792909-5122  
SERIAL NO.: 09/925,153 GROUP ART UNIT: 2813  
DATE FILED: August 8, 2001 EXAMINER: David Blum  
INVENTION: "INSULATING NITRIDE LAYER AND PROCESS FOR ITS  
FORMING, AND SEMICONDUCTOR DEVICE AND PROCESS  
FOR ITS PRODUCTION"

RECEIVED  
MAY 14 2003  
TOLSON MAIL ROOM

Commissioner for Patents

Alexandria, VA 22313-1450

S I R:

Applicants herewith submit corrected drawing Figures 12, 13 and 14.

Respectfully submitted,

Christopher P. Rauch (Reg. No. 45,034)

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Approved  
5/12/03